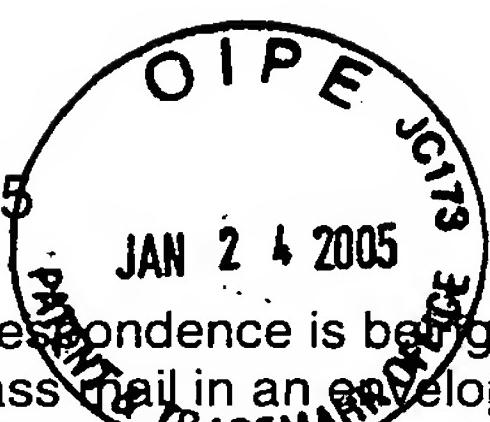


IFW

Docket No.: P2002,0645



I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date indicated below:

By: Werner Stemmer

Date: January 18, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/632,752 Confirmation No: 4660
Applicant : Frank-Michael Kamm et al.
Filed : August 1, 2003
Title : Reflective Mirror for Lithographic Exposure and Production Method
Art Unit : 2812
Examiner : Olivia T. Luk

Docket No. : P2002,0645
Customer No. : 24131

R E S P O N S E

Hon. Commissioner for Patents

Sir:

Responsive to the Office Action dated December 21, 2004, the following remarks are made:

In deference to the restriction requirement on pages 2 and 3 of the above-identified Office Action, applicants elect group II, claims 11-18, for prosecution at this time.

Applicants request a rejoinder under MPEP §821.04.

In view of the foregoing, the early issuance of an Action on the merits of claims 11-18 is solicited.

Respectfully submitted,



For Applicants

WERNER H. STEMER
REG. NO. 34,956

Date: January 18, 2005

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